

## Update on the RD50 project NitroStrip

*Wednesday 7 June 2017 14:40 (20 minutes)*

The new NitroStrip p-on-n sensors were fabricated in CNM Barcelona within the RD50 collaboration on 4 different kinds of wafers: FZ, DOFZ, HR FZ Nitrogenated wafer and MCz. Here it will be shown electrical measurements without irradiation for some samples of those strip sensors.

**Primary author:** BASELGA BACARDIT, Marta (KIT - Karlsruhe Institute of Technology (DE))

**Presenter:** BASELGA BACARDIT, Marta (KIT - Karlsruhe Institute of Technology (DE))

**Session Classification:** Defect and Material Engineering